

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Kenji YAMAZOE et al.

Serial No.: 10/783,218

Group Art Unit: 1756

Conf. No.: 6685

Examiner: Stephen D. Rosasco

Filed: February 20, 2004

For: MASK AND ITS MANUFACTURING METHOD, EXPOSURE, AND DEVICE FABRICATION METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 22, 2006, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.